



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of )  
Ravkin et al. ) Examiner: Wilkins III, H.  
Application No: 10/607,611 ) Art Unit: 1742  
Filed: June 27, 2003 ) Docket No: LAM2P428  
For: APPARATUS AND METHOD FOR ) Date: October 21, 2005  
DEPOSITING AND PLANARIZING THIN FILMS)  
OF SEMICONDUCTOR WAFERS )

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on October 21, 2005.

Signed: Justine Stamm

Justine Stamm

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated September 21, 2005, Applicants hereby elect to prosecute, without traverse, Species of Figures 2A, 2B, claims 1, 2, 4-9, 13-23, and 25-35 in the above-identified Patent Application.

Applicants believe that no fees are required in the filing of this Response. However, if it is determined that any fees are required, the Commissioner is authorized to charge such fees to our Deposit Account No. 50-0805 (Order No. LAM2P428). Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number set out below.

Respectfully submitted,  
MARTINE PENILLA & GENCARELLA, LLP

Albert S. Penilla, Esq.  
Reg. No. 39,487

710 Lakeway Drive, Suite 200  
Sunnyvale, CA 94085  
Telephone (408) 749-6900  
Customer No. 25920

Attorney Docket No: LAM2P428